

10/517049 #3

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Yasushi KURATA et al.**

Serial Number: **Not Yet Assigned**
 (**§371 of international application No. PCT/JP03/06769**)

Filed: **December 3, 2004**

For: **POLISHING SLURRY AND POLISHING METHOD**

Attorney Docket No.: **043062**

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 3, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449. References AB to AG are cited in the enclosed international search report. References AA, AH to AL are cited in the specification.

A copy of each of the references is enclosed herewith, except for the U.S. reference.

In the event there are any fees due in connection with the filing of this paper, please charge
Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosures: PTO-1449; References (11) and international search report.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KC/

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| INFORMATION DISCLOSURE STATEMENT PTO-1449 | Atty. Docket No. 043062 | Serial No. New Appln: 10/517049 |
| | Applicant(s): Yasushi KURATA et al. | |
| | Filing Date: December 3, 2004 | Group Art Unit: |

U.S. PATENT DOCUMENTS

| Examiner Initial | Document No. | Name | Date | Class | Subclass | Filing Date (If appropriate) |
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| | AA 4,944,836 | Beyer et al. | 07/31/90 | | | |

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| AC | 2001-176826 | 06/29/01 | Japan | Yes. Cited in the int'l. search report. |
| AD | 2000-340532 | 12/08/00 | Japan | Abstract. Cited in the int'l. search report. |
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| AF | 11-135467 | 05/21/99 | Japan | Abstract. Cited in the int'l. search report. |
| AG | WO 94/28194 | 05/25/94 | PCT | Cited in the int'l. search report. |
| AH | 02-278822 | 11/15/90 | Japan | Abstract. Cited in the specification. |
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| AL | F. B. Kaufman et al.; Journal of the Electrochemical Society, Vol. 138, No. 11, pp.3460-3465, November 1991. Cited in the specification. | | |
| Examiner | /Kin Chan Chen/ | Date Considered | 03/25/2009 |

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KC/